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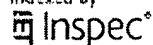
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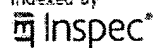
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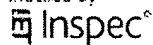
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View: 1-

- ☐ 1. **A pneumatically actuated full in-channel microvalve with MOSFET-like full channel networks**
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16. **A normally-closed, bimetallically actuated 3-way microvalve for pneumatic applications**
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25. **Design of reconfigurable composite microsystems based on hardware/s principles**
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IEEE CNF IEEE Conference Proceeding

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IEEE STD IEEE Standard

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- ☐ **26. Observation of on-chip electrophoresis microcapillary using confocal las microscopy**
 Etoh, S.; Fujimura, T.; Hattori, R.; Kuroki, Y.;
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- ☐ **27. Modulation of drug delivery rate by hydrogel-incorporating MEMS device**
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- ☐ **28. Electronic fountain pen - a highly integrated stand-alone microdosage sy**
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Tingrui Pan; Brown, J.D.; Ziaie, B.;
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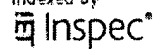
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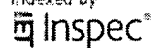
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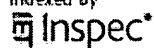
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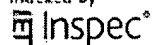
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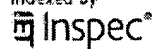
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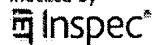
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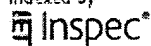
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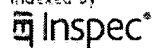
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